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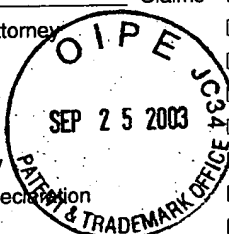


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JH Ref P68950USO Today's Date SEPTEMBER 25, 2003
Serial/Patent No. 10/607,052
Applicant, Patentee, Assignee SUNG-KWAN LEE, ET AL.
Filing Date/Patent Date JUNE 27, 2003

The following has been received in the U.S. Patent & Trademark Office on the date stamped hereon:

- ☐ _____ pp. Specification & _____ Claims
- ☐ Combined Declaration, Power of Attorney
- ☐ Preliminary Amendment
- ☐ Rule 53 (b) Application
- ☐ Rule 53 (d) /RCE Application
- ☒ Claim to Priority and Certified Copy
- ☐ Substitute ☐ Subsequent Declaration
- ☐ Maintenance Fee
- ☐ Drawings _____ Sheets _____ Formal _____ Informal
- ☐ Assignment/Change of Name
- ☐ Small Entity Declaration
- ☐ Check for \$ _____
- ☐ Response to Office Action
- ☐ Disclosure Statement-IDS
- ☐ Copies of References
- ☐ Request for Refund
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- ☐ Petition for XOT
- ☐ Notice of Appeal/Brief
- ☐ Sequence Listing
- ☐ Issue Fee Transmittal
- ☐ Other _____



JH 11/01 DUE DATE _____
Person filing YSH/dj

JACOBSON HOLMAN PLLC
400 SEVENTH STREET, N.W.
WASHINGTON, D.C. 20004



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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Sung-Kwon LEE, et al.

Serial No.: 10/607,052

Group Art Unit: 2812

Filed: June 27, 2003

Examiner: Not Yet Assigned

Title: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE CAPABLE OF
REDUCING SEAM GENERATIONS

* * * * *

CLAIM FOR PRIORITY
UNDER 35 U.S.C. §119

Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 25, 2003

Sir:

The benefit of the filing date of prior foreign application No. 2002-84097, filed in Korea on December 26, 2002, is hereby requested and the right of priority provided in 35 U.S.C. §119 is hereby claimed.

In support of this claim, filed herewith is a certified copy of said original foreign application.

Respectfully submitted,

By: Yoon S. Ham by Sign C. Balue
Yoon S. Ham
Reg. No. 45,307 reg No 40,495

JACOBSON HOLMAN, PLLC
The Jenifer Building
400 Seventh Street, N.W.
Washington, D.C. 20004-2201
Telephone: (202) 638-6666

Atty. Docket No.: P68950US0
YSH:dj

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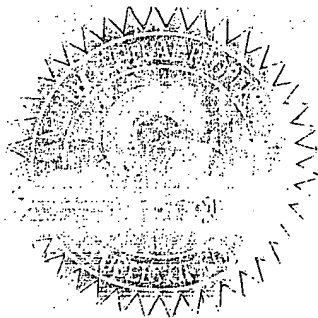
별첨 사본은 아래 출원의 원본과 동일함을 증명함.

This is to certify that the following application annexed hereto
is a true copy from the records of the Korean Intellectual
Property Office.

출원번호 : 10-2002-0084097
Application Number

출원년월일 : 2002년 12월 26일
Date of Application DEC 26, 2002

출원인 : 주식회사 하이닉스반도체
Applicant(s) Hynix Semiconductor Inc.



2003 년 06 월 27 일

특 허 청

COMMISSIONER





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JH Ref

P68950US0

Today's Date

SEPTEMBER 25, 2003

Serial/Patent No.

10/607,052

Applicant, Patentee, Assignee

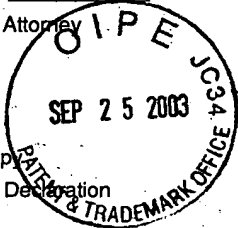
SUNG-KWON LEE, ET AL.

Filing Date/Patent Date

JUNE 27, 2003

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| <input type="checkbox"/> Assignment/Change of Name | <input type="checkbox"/> Other _____ |
| <input type="checkbox"/> Small Entity Declaration | |
| <input type="checkbox"/> Check for \$ _____ | |



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DUE DATE

Person filing

YSHldj

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Title: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE CAPABLE OF
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CLAIM FOR PRIORITY
UNDER 35 U.S.C. §119

Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 25, 2003

Sir:

The benefit of the filing date of prior foreign application
No. 2002-37257, filed in Korea on June 29, 2002, is hereby
requested and the right of priority provided in 35 U.S.C. §119 is
hereby claimed.

In support of this claim, filed herewith is a certified copy
of said original foreign application.

Respectfully submitted,

By: Yoon S. Ham by Sigr C. Jolley
Yoon S. Ham
Reg. No. 45,307 Reg. No. 40,495

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Atty. Docket No.: P68950US0
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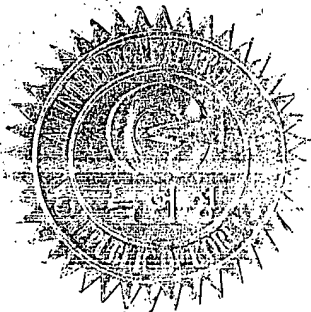
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This is to certify that the following application annexed hereto
is a true copy from the records of the Korean Intellectual
Property Office.

출원 번호 : 10-2002-0037257
Application Number

출원 년 월 일 : 2002년 06월 29일
Date of Application JUN 29, 2002

출원인 : 주식회사 하이닉스반도체
Applicant(s) Hynix Semiconductor Inc.



2003 년 05 월 14 일

특 허 청

COMMISSIONER

